

The Abstract has been amended. A revised Abstract is attached.

ABSTRACT

A method of manufacturing plasma display panels using <u>a_substrate holder (1)</u> for deposition on a substrate (13) of the plasma display panel. <u>The Substrate substrate holder (1)</u> is configured with plural frames (2), and the substrate (13) of the plasma display panel is held by its periphery with at least one of these frames (2). <u>A frame Frame (2)</u> holding the substrate (13) has <u>a_protrusion (5)</u> extending to <u>a_non-deposition face (13b)</u> of the substrate held in such a way as to surround the substrate (13). Since the protrusion (5) acts as a blocking sheet, attachment of a deposition material passing through <u>an opening (4) on the substrate holder (1) and reaching onto the non-deposition face (13b) of the substrate (13) is suppressed.</u>

Respectfully submitted,

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Attachments:

Abstract

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